

**DECLARATION
and
DESIGNATION OF CORRESPONDENCE ADDRESS**



As an inventor named below, I hereby declare that:

My residence, post office address and citizenship are stated below next to my name.

I believe I am the original, first and sole inventor (if only one inventor is named below) or an original, first and joint inventor (if plural inventors are named below) of the subject matter which is claimed and for which a patent is sought in the specification DP-303893 entitled

**A NON-THERMAL PLASMA REACTOR HAVING INDIVIDUALLY
RETAINED POSITIVE AND NEGATIVE REACTOR PLATES**

I have reviewed and understand the contents of the above-identified specification including the claims, as amended by any amendment referred to in this Declaration.

I acknowledge my duty to disclose to the Patent and Trademark Office all information known to me to be material to patentability as defined in title 37 Code of Federal Regulations, Section 1.56.

I further declare that all statements made above of my own knowledge are true, that all statements made above on information and belief are believed to be true, and that these statements were made with the knowledge that willful false statements and the like are punishable by fine or imprisonment, or both, under title 18 United States Code, Section 1001 and may jeopardize the validity of the application or any patent issuing thereon.

Address all communications to
VINCENT A. CICHOSZ
DELPHI TECHNOLOGIES, INC.
Legal Staff
P.O. Box 5052
Mail Code: 480-414-420
Troy, Michigan 48007-5052

Telephone: (248) 267-5555

Inventor's signature
Full name :
Residence :
Post office address:

Michael R Foster
MICHAEL RALPH FOSTER
COLUMBIAVILLE, MI
5200 STANLEY ROAD
COLUMBIAVILLE, MI 48421

Date 04 JAN 01
Citizenship: US

BEST AVAILABLE COPY